



500.36904X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: H. Miura, et al.

Application No.: 09/254,939

Filing Date: March 17, 1999

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE HAVING
TRENCH ELEMENT SEPARATION STRUCTURE

Art Unit: 2814

Examiner: Anh D. Mai

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 1, 2004

Sir:

In response to the Office Action mailed June 1, 2004, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.